



**ELECTRONIC COPY**

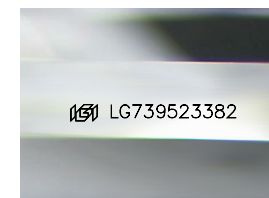
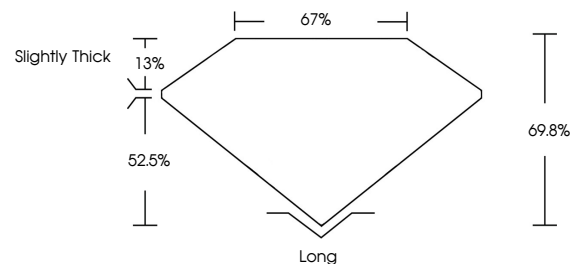
LG739523382  
Report verification at igi.org



October 13, 2025  
IGI Report Number **LG739523382**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **11.26 X 7.95 X 5.55 MM**  
**GRADING RESULTS**  
Carat Weight **5.01 CARATS**  
Color Grade **D**  
Clarity Grade **INTERNALLY FLAWLESS**

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**PROPORTIONS**

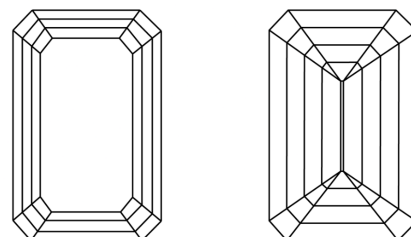


Sample Image Used

**GRADING RESULTS**

Carat Weight **5.01 CARATS**  
Color Grade **D**  
Clarity Grade **INTERNALLY FLAWLESS**

**CLARITY CHARACTERISTICS**



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **VERY GOOD**  
Fluorescence **NONE**  
Inscription(s) **IGI LG739523382**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**KEY TO SYMBOLS**

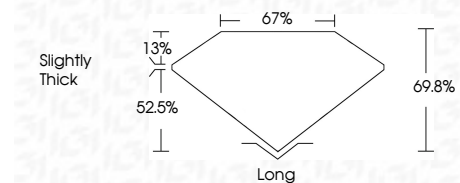
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **VERY GOOD**  
Fluorescence **NONE**  
Inscription(s) **IGI LG739523382**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



**IGI**



October 13, 2025  
IGI Report No LG739523382  
**EMERALD CUT**  
11.26 X 7.95 X 5.55 MM  
5.01 CARATS  
Color Grade **D**  
Clarity Grade **IF**  
Table **67%**  
Girdle **Slightly Thick**  
Culet **Long**  
Polish **EXCELLENT**  
Symmetry **VERY GOOD**  
Fluorescence **NONE**  
Inscription(s) **IGI LG739523382**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa